

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re the Application of

Hideki KOMATSUDA et al.

Application No.: 09/396,582

Filed: September 15, 1999

For: EXPOSURE APPARATUS AND EXPOSURE METHOD USING SAME

Group Art Unit: 2882

Examiner: C. Church

Docket No.: 105203

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**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

Applicants hereby request continued examination and entry and consideration of the attached submission under 37 C.F.R. §1.114. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 126045 in the amount of ☒ \$740.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Director is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

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JAO:MAC/ccs

Date: December 17, 2001

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